Electronic A	cknowledgement Receipt		
EFS ID:	3339761		
Application Number:	10054629		
International Application Number:			
Confirmation Number:	5778		
Title of Invention:	LOW DEFECT DENSITY SILICON HAVING A VACANCY-DOMINATED CORE SUBSTANTIALLY FREE OF OXIDATION INDUCED STACKING FAULTS		
First Named Inventor/Applicant Name:	Chang Bum Kim		
Customer Number:	321		
Filer:	Richard A. Schuth/Darlene Pearman		
Filer Authorized By:	Richard A. Schuth		
Attorney Docket Number:	MEMC 01-0151(2960.1)		
Receipt Date:	21-MAY-2008		
Filing Date:	22-JAN-2002		
Time Stamp:	18:05:26		
Application Type:	Utility under 35 USC 111(a)		

Submitted with Payment	no
- Casimiliou intii i ajimont	1 110

# File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Power of Attornev	29601.pdf	128644	no	3
'	rowel of Attorney	29601.pai	26219529539fd487afe6582b633f4178a 772ef74	no	, s
Warnings:					

Warnings:	W	ar	nı	ng	s:
-----------	---	----	----	----	----

Information:

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

#### New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

### National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

## New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.